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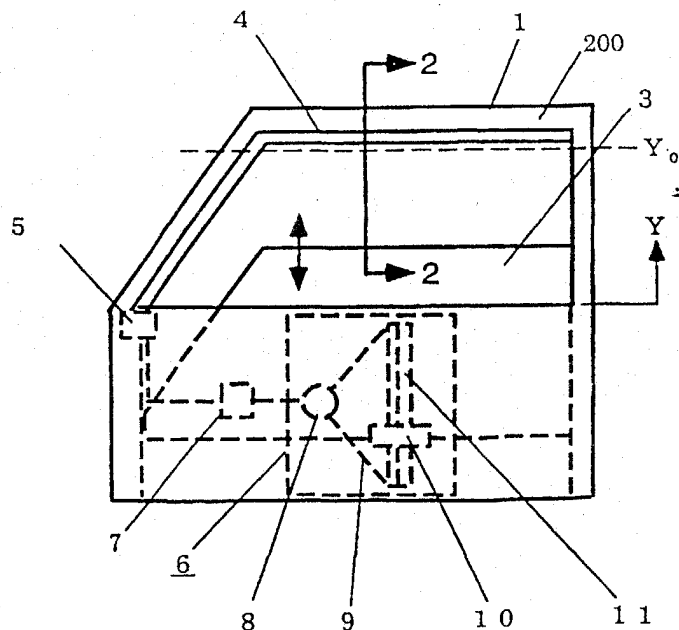
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(54) Title: PRESSURE-SENSITIVE SENSOR, OBJECT DETECTING DEVICE, AND OPENING-CLOSING DEVICE

(57) Abstract

In a pressure-sensitive sensor for detecting seizure of an object in the window frame or the like, support means (13) is more flexible than a piezoelectric sensor (12), and the support means (13) is easily deformed together with the piezoelectric sensor (12) without impeding the deformation of the piezoelectric sensor (12), and an output signal is issued from the piezoelectric sensor (12) depending on this deformation. Accordingly, when detecting the contact of an object with a pressure-sensitive sensor (4) by a judging device, the pressure-sensitive sensor (4) for generating an output signal of a sufficient magnitude for detection can be presented.



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